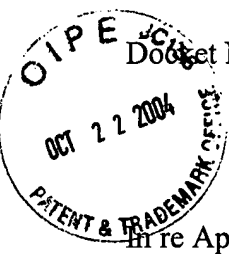


1764
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Docet No. 60040-0015

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Christopher HERTZLER, et al.) Confirmation No.: 4676
Serial No.: 09/846,495) Examiner: Hien Thi TRAN
Filing Date: April 30, 2001) Art Unit: 1764

For: TREATMENT SYSTEM FOR REMOVING HAZARDOUS SUBSTANCES FROM A SEMICONDUCTOR PROCESS WASTE GAS STREAM

AMENDMENT AND RESPONSE TRANSMITTAL

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

☒ No additional fee is required.
☒ Also attached: Postcard.

The fee has been calculated as shown below:

	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE
Total Claims	22	22	0	\$18.00 =	\$0.00
Independent Claims	4	4	0	\$88.00 =	\$0.00
Multiple claims newly presented					\$0.00
Fee for extension of time					\$0.00
TOTAL FEE DUE					\$0.00

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 50-1302, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

HICKMAN PALERMO TRUONG & BECKER LLP

John D. Henkhaus
John D. Henkhaus, Registration No. 42,656

1600 Willow Street
San Jose, CA 95125
(408) 414-1080, Ext. 203 JDH/ds
Date: 10/18/04
Facsimile: (408) 414-1076

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450

on 10/18/04 by Darci Sakamoto
Darci Sakamoto



AMENDMENT UNDER 37 C.F.R. § 1.111

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	Christopher HERTZLER, et al.)	Confirmation No.: 4676
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Serial No.:	09/846,495)	Examiner: Hien Thi TRAN
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SEMICONDUCTOR PROCESS WASTE GAS STREAM

Mail Stop Amendment
Commissioner for Patents
P. O. Box 1450
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RESPONSE TO OFFICE ACTION

Sir:

This is in response to the Office Action mailed September 24, 2004, the shortened statutory period for which runs until October 24, 2004. Please revise the subject application as indicated below.

Remarks begin on page 2 of this paper.